

Notice of References Cited	Application/Control No. 10/617,892	Applicant(s)/Patent Under Reexamination JOHNSON ET AL.	
	Examiner <i>J</i> 8/19/05 James A. Menefee	Art Unit 2828	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Hegblom et al., "Small efficient vertical cavity layers with tapered oxide apertures," Electronics Letters, vol. 34, no. 9, 30 April 1998, p. 895-897.
	V	Bond et al., "Aperture Placement Effects in Oxide Defined Vertical-Cavity Surface-Emitting Lasers," IEEE Photonics Technology Letters, vol. 10, no. 10, Oct. 1998, p. 1362-1364.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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